Docket No.

215930US99

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Dirk C. JORDAN, et al.

GAU:

2813

11/

SERIAL NO: 09/986,899

UAU.

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EXAMINER: HOGANS, D.L.

FILED:

November 13, 2001

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES

FOR:

UTILIZING THE FORMATION OF A COMPLIANT SUBSTRATE HAVING A NIOBIUM

CONCENTRATION

## REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a three month extension of time be granted to September 24, 2002 for

☑ filing a response to the Official Action dated:

May 24, 2002.

responding to the requirements in the Notice of Allowability dated:

☐ filing the Formal Drawings. The Issue Fee due

has been timely filed.

responding to the Notice to File Missing Parts of Application dated:

☐ filing a Notice of Appeal. A timely response to the final rejection, due

has been filed.

☐ filing an Appeal Brief. A Notice of Appeal was filed on:

☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$920.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

09/25/2002 SSITHIB1 00000065 09986899

01 FC:117

920.00 OP

Respectfully Submitted,

OBLON, STIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Richard L. Treanor

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(OSMMN 10/01)